

Notice of References Cited	Application/Control No. 10/529,679		Applicant(s)/Patent Under Reexamination VERSCHUREN, COEN ADRIANU	
	Examiner Kezhen Shen		Art Unit 2627	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0018404	02-2002	Awano et al.	369/13.07
*	B	US-6,424,601	07-2002	Oonuki et al.	369/13.08
*	C	US-2002/0191497	12-2002	Verschuren et al.	369/13.14
*	D	US-2003/0026173	02-2003	Verschuren, Coen Adrianus	369/13.06
*	E	US-6,519,211	02-2003	Murakami et al.	369/13.08
*	F	US-6,671,233	12-2003	Shimazaki et al.	369/13.07
*	G	US-6,700,837	03-2004	Verschuren, Coen Adrianus	369/13.09
*	H	US-5,283,770	02-1994	Nakao et al.	369/13.07
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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